

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application <u>09/900,613</u> <u>10/826,571</u>		OFGS File No. <u>P/3241-1826D1</u>				
		Applicant <u>Masamichi Fujiwara et al.</u>						
		Filing Date <u>July 6, 2001</u> <u>April 16, 2004</u>		Group Art Unit <u>2874</u>				
U.S. PATENT DOCUMENTS								
Examiner Initial	Document Number			Date	Name	Class	Sub-class	Filing Date If Appropriate
FOREIGN PATENT DOCUMENTS								
	Document Number			Date	Country	Class	Sub-class	Translation
								Yes No
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
JDL	A Multiwavelength Source Having Precise Channel Spacing for WDM Systems, J.J. Veselka and S.K. Korotky, Fellow, IEEE Photonics Technology Letters, Vol. 10, No. 7, July 1998							
JDL	More Than 1000 Channel Optical Frequency Chain Generation from Single Supercontinuum Source with 12.5 GHz Channel Spacing, H. Takara et al., Electronics Letters, Vol. 36, No. 25, December 7, 2000							
JDL	3.17-THz Frequency-Difference Measurement Between Lasers Using Two Optical Frequency Combs, M. Kourogi et al., IEEE Photonics Technology Letters, Vol. 8, No. 4, April 1996							
JDL	Modulation Characteristics of Waveguide-Type Optical Frequency Comb Generator, T. Saitoh et al., Journal of Lightwave Technology, Vol. 16, No. 5, May 1998							
JDL	Tunable Gain Equalization Using a Mach-Zehnder Optical Filter in Multistage Fiber Amplifiers, K. Inoue et al., IEEE Photonics Technology Letters, Vol. 3, No. 8, August 1991							
JDL	3 Tbit/s (160 Gbit/s x 19 channel) Optical TDM and WDM Transmission Experiment, S. Kawanishi et al., Electronics Letters, Vol. 35, No. 10, May 13, 1999							
Examiner <u>John D. Lee</u>		Date Considered <u>14 SEPTEMBER 2005</u>						
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